

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of :

Paul RICH et al. :

Serial No. [NEW] :

Filed: January 21, 2004 :

For: ELECTROSTATIC CLAMPING OF THIN WAFERS IN PLASMA
PROCESSING VACUUM CHAMBER

PRELIMINARY AMENDMENT

U.S. Patent and Trademark Office
2011 South Clark Place
Customer Window, **Mail Stop Patent Application**
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Sir:

Preliminary to the examination of the above-identified application,
please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which
begins on page 3 of this paper.

Remarks begin on page 5 of this paper.